## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Robert Hutteman, et al.

Serial No.:

N/A

Filed:

Herewith

Title:

THIN FILM RESISTOR DEVICE AND METHOD

OF MANUFACTURE THEREFOR

Grp./A.U.:

N/A

Examiner:

N/A

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **PRELIMINARY AMENDMENT**

Before examination of the above-identified application, please amend it as follows: